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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/524,066 03/13/2000		MARK D. HETHERINGTON	CE08291R	6510	
22917	7590	05/06/2004		EXAMINER	
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				DATE MAILED: 05/06/2004	ું 5

Please find below and/or attached an Office communication concerning this application or proceeding.

<u> </u>		Application	n No.	Applicant(s)						
· ·		09/524,066		HETHERINGTON ET AL.						
Offic	e Action Summary	Examiner		Art Unit						
		Clemence	Han	2665						
	ILING DATE of this communica			orrespondence add	ress					
Period for Reply  A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).										
Status										
1) Respons	sive to communication(s) filed									
,—	This action is <b>FINAL</b> . 2b)⊠ This action is non-final.									
•	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.									
Disposition of Claims										
4a) Of the 5) ☐ Claim(s) 6) ☑ Claim(s) 7) ☑ Claim(s)	Claim(s) 9 and 11-27 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  Claim(s) is/are allowed.  Claim(s) 9 and 11-21 is/are rejected.  Claim(s) 22-27 is/are objected to.  Claim(s) are subject to restriction and/or election requirement.									
Application Pape	rs	•								
9) The specification is objected to by the Examiner.  10) The drawing(s) filed on 18 February 2004 is/are: a) accepted or b) objected to by the Examiner.  Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).  11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.										
Priority under 35 U.S.C. § 119										
<ul> <li>12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No.</li> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>										
Attachment(s)										
1) Notice of Refere 2) Notice of Drafts	ences Cited (PTO-892) person's Patent Drawing Review (PTC closure Statement(s) (PTO-1449 or PT il Date		4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:		1-152)					

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#### **DETAILED ACTION**

### Response to Amendment

1. Responsive to amendment received on February 18, 2004, claims 1–8 and 10 are cancelled and amended claims 9, 11–13, 15 and new claims 20–27 are entered as requested.

### **Drawings**

2. The drawings are objected to because of the missing sequence number 13 as an input to the frame serializer in figure 3. According to figure 3, the frames with the sequence number 12, 15, 16 and 99 are the inputs to the frame serializer.

According to the specification, the frames with the sequence number 12, 13, 15, 16 and 99 are the inputs to the frame serializer. A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

# Claim Rejections - 35 USC § 103

- 3. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
- 4. Claim 9, 12–16 and 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Rezaiifar et al. (US Patent 6,408,003) in view of Jarvinen et al. (US Patent 5,526,366).

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In regarding to claim 9, Rezaiifar teaches a method of providing RLP data checking comprising: receiving a plurality of RLP data frames 70; and passing the reclassified frame to a RLP data detector 174. Rezaiifar, however, does not teach identifying from the RLP data frames a suspected bad frame and reclassifying the suspected bad frame to form a reclassified frame, wherein the reclassified frame is an erasure. Jarvinen teaches identifying from the RLP data frames a suspected bad frame 206 and reclassifying the suspected bad frame to form a reclassified frame, wherein the reclassified frame is an erasure 207. It would have been obvious to one skilled in the art to modify Rezaiifar to identify and reclassify the suspected bad frame as taught by Jarvinen in order to remove bad frame (Column 1 Line 61).

In regarding to claim 12, Rezaiifar teaches the steps of characterizing a received a valid data frame as an invalid data frame responsive to a data frame sequence parameter (Column 8 Line 58-61).

In regarding to claim 13, Rezaiifar teaches sequencing the plurality of RLP data frames according to data frame sequence identifiers to form a data frame sequence (Figure 3).

In regarding to claim 14, Rezaiifar teaches the steps of modifying the data frame sequence responsive to the data frame sequence parameter (Column 8 Line 58 – Column 9 Line 4).

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In regarding to claim 15, Rezaiifar teaches the steps of validating the data frame sequence (Column 8 Line 58 – Column 9 Line 4).

In regarding to claim 16, Rezaiifar teaches receiving the next data frame sequence before the steps of validating the data frame sequence (Column 7 Line 20-22).

In regarding to claim 20, Rezaiifar teaches the step of identifying a suspected bad frame comprises retrieving a data frame sequence identifier from a received valid data frame; and comparing the data frame sequence identifier with a data frame sequence parameter (Column 8 Line 58 – Column 9 Line 4).

5. Claim 11, 17–19 and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Rezaiifar et al. in view of Jarvinen et al. and further in view of Saeijs et al. (US Patent 5,596,581).

In regarding to claim 11, Rezaiifar in view of Jarvinen teaches a method of providing RLP data checking comprising: receiving a plurality of RLP data frames 70; identifying from the RLP data frames a suspected bad frame and reclassifying the suspected bad frame to form a reclassified frame and passing the reclassified frame to a RLP data detector 174. Rezaiifar in view of Jarvinen, however, does not teach the steps of inserting a place holder frame. Saeijs teaches the steps of inserting a place holder frame (Figure 8c). It would have been obvious to one

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skilled in the art to modify Rezaiifar in view of Jarvinen to insert a place holder frame as taught by Saeijs in order to keep the data frame sequence synchronized.

In regarding to claim 17, Rezaiifar teaches an apparatus for RLP data checking comprising: a frame serialization stage, the frame serialization stage coupled to receive a plurality of RLP data frames 70, each of the plurality of RLP data frames having a sequence number (Column 8 Line 58 - Column 9 Line 4) and the frame serialization stage being operable to provide a sequenced data frame output (Figure 3). Rezaiifar, however, does not teach a frame filter coupled to the frame serialization stage to receive the sequenced data frame output and to provide a filtered data frame output; and wherein, place holder frames are inserted in the sequenced data frame output for suspected omitted frames, and erasure frames are inserted in the filtered data frame output for suspected bad data frames. Jarvinen teaches erasure frames 207 are inserted in the filtered data frame output for suspected bad data frames. It would have been obvious to one skilled in the art to modify Rezaiifar to identify and reclassify the suspected bad frame as taught by Jarvinen in order to remove bad frame (Column 1 Line 61). Rezaiifar in view of Jarvinen, however, does not teach the steps of inserting a place holder frame. Saeijs teaches the steps of inserting a place holder frame (Figure 8c). It would have been obvious to one skilled in the art to modify Rezaiifar in view of Jarvinen

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to insert a place holder frame as taught by Saeijs in order to keep the data frame sequence synchronized.

In regarding to claim 18, Rezaiifar teaches receiving a next expected sequence number (Column 10 Line 51-65).

In regarding to claim 19, Rezaiifar teaches the frame serialization stage is coupled to an output of a frame CRC check stage 88 and the frame filter is coupled to an input of an RLP data layer 174.

In regarding to claim 21, Saeijs teaches the plurality of RLP data frames transmitted across a plurality of channels (Column 13 Line 37–45).

### Allowable Subject Matter

- 6. The indicated allowability of claim 10–19 are withdrawn in view of the newly discovered reference(s) to Jarvinen et al.. Rejections based on the newly cited reference(s) are described under the 103(a) rejection above.
- 7. Claim 22–27 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 8. The following are statements reasons for the indication of allowable subject matter:

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In regarding to claim 22, prior art of the record, cited herein, fails to disclose the data frame sequence parameter as a function, at least in part, of a number of channels that the plurality of RLP data frames can be transmitted across.

In regarding to claim 23, prior art of the record, cited herein, fails to disclose the data frame sequence parameter as a function, at least in part, of a number of channels determined to be in active use.

In regarding to claim 25, prior art of the record, cited herein, fails to disclose at least one of the channels as a Discontinuous Transmission (DTX) channel.

In regarding to claim 26, prior art of the record, cited herein, fails to disclose occurrence of the step of reclassifying the suspected bad frame dependent on whether a channel is determined to be currently in active use.

In regarding to claim 27, prior art of the record, cited herein, fails to disclose occurrence of the step of reclassifying the suspected bad frame dependent on an elapsed time from receiving a previous data frame sequence identifier.

## Response to Arguments

9. Applicant's arguments with respect to claim 9 and 11–27 have been considered but are moot in view of the new ground(s) of rejection.

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## Conclusion

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10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Clemence Han whose telephone number is(703) 305-0372. The examiner can normally be reached on Monday-Friday 8 to 5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Huy Vu can be reached on (703) 308-6602. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Clemence Han Examiner Art Unit 2665

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